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BY EXPRESS MAIL ON  
August 31, 2001  
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Box PATENT APPLICATION  
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Washington, DC 20231

RECORD OF TRANSMITTAL

INVENTORS: (1) Jun OSANAI  
(2) Hisashi HASEGAWA  
(3) Sumio KOIWA  
(4) Kazutoshi ISHII

TITLE: COMPLEMENTARY MOS SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME

DOCKET NO: S004-4393

S I R:

Kindly find enclosed herewith for filing the documents checked below. Any fees or charges not covered by the accompanying check should be charged to our Deposit Account No. 01-0268.

APPLICABLE ITEMS CHECKED:

PATENT APPLICATION (pages 1-168 of specification, 73 claims (pages) 1-71 and abstract of the disclosure (page 1))

DESIGN APPLICATION (specification, claim, declaration and power of attorney and photograph(s))

FORMAL DRAWINGS ( 55 sheets) (8.5 x 11)

INFORMAL DRAWINGS ( \_\_\_\_\_ sheets)

RECORDATION FORM COVER SHEET and ASSIGNMENT  
(to be recorded and returned to the undersigned)

XX PRIORITY CLAIM - applicants claim the benefit of priority of the following applications:

Japanese Patent Application No. 2000-265495 filed Sept. 1, 2000;  
Japanese Patent Application No. 2000-299549 filed Sept. 29, 2000;  
Japanese Patent Application No. 2000-331080 filed Oct. 30, 2000;  
Japanese Patent Application No. 2001-035800 filed Feb. 13, 2001;  
Japanese Patent Application No. 2001-044068 filed Feb. 20, 2001;  
Japanese Patent Application No. 2001-113049 filed Apr. 11, 2001;  
Japanese Patent Application No. 2001-118539 filed Apr. 17, 2001;  
Japanese Patent Application No. 2001-188051 filed Jun. 21, 2001;  
Japanese Patent Application No. 2001-204758 filed Jul. 5, 2001;  
Japanese Patent Application No. 2001-241293 filed Aug. 8, 2001;  
Japanese Patent Application No. 2001-241294 filed Aug. 8, 2001;  
Japanese Patent Application No. 2001-241297 filed Aug. 8, 2001;  
Japanese Patent Application No. 2001-241298 filed Aug. 8, 2001;  
Japanese Patent Application No. 2001-241299 filed Aug. 8, 2001;  
Japanese Patent Application No. 2001-241829 filed Aug. 9, 2001;  
Japanese Patent Application No. 2001-243944 filed Aug. 10, 2001;

XX PRIORITY DOCUMENT(s)

Enclosed  Not Enclosed

VERIFIED STATEMENT TO ESTABLISH SMALL ENTITY STATUS

XX EXPRESS MAIL CERTIFICATION

OTHER -

XX FEE

A check is enclosed for the following official fees:

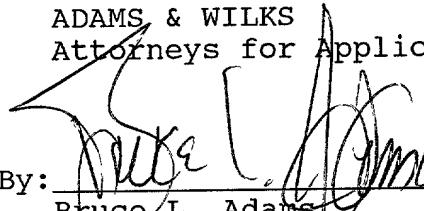
	Large Entity	Small Entity
<u>XX</u> Basic Filing Fee	\$ 710.00	\$
<u>4</u> Independent Claims in Excess of 3	\$ 320.00	\$
<u>53</u> Total Claims in Excess of 20	\$ 954.00	\$
<input type="checkbox"/> Multiple Claim Fee	\$	\$

Assignment Recordal Fee                  \$                  \$  
TOTAL                  \$1984.00          \$

Respectfully submitted,

ADAMS & WILKS  
Attorneys for Applicants

By:

  
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Reg. No. 25,386

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Re: New patent application of Jun OSANAI et al.  
for COMPLEMENTARY MOS SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME

comprising transmittal letter, title, specification (pgs.1-168),  
73 claims (pgs.1-71), abstract of the disclosure (pg.1), 55  
sheets of formal drawings containing thereon Figs. 1-91, express  
mail certification and check in the amount \$1984.00

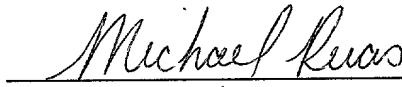
Attorney's Docket No: S004-4393

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Michael Ruas